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Docket No. 740756-2659

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

)

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/678,139

Filed: October 6, 2003

For: METHOD FOR FABRICATING

SEMICONDUCTOR THIN FILM

) Group Art Unit: 2822

) Examiner: Maria F. Guerrero

) Confirmation No. 9428

Date: October 11, 2005

CERTIFICATE OF MAILING OR TRANSMISSION [37 CFR 1.8(a)]

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Signature

Name: Jegger I Compile

AMENDMENT

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed July 11, 2005, please amend the above identified application as follows.

W681277L1